

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RESPONSE TO OFFICE ACTION MAILED APRIL 6, 2005

Atty. Docket No. (Opt.)
UBAT1360-2

Applicants: Michael A. Guillorn, et al.

Application Number

Filed

10/681,565

October 8, 2003

For:

Gated Fabrication of Nanostructure Field Emission Cathode Material Within a Device

Group Art Unit

Confirmation Number:

2812

9447

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Certification Under 37 C.F.R. §1.10

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail Post Office to Addressee in an envelope bearing Express Mail mailing label number **EQ 454150548 US** addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 on March 3, 2006.

John J. Bruckner

This is in response to the Office Action dated November 3, 2005. In response to the Office Action, Applicants respectfully request that the Examiner reconsider this application in view of the following amendments and the remarks set forth below. Please amend the Application as follows: